



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takatomo YAMAGUCHI et al.

Group Art Unit: 1792

Application No.: 10/574,568

Examiner: K. CHEN

Filed: August 7, 2006

Docket No.: 127569

For: SUBSTRATE PROCESSING APPARATUS, SUBSTRATE HOLDER, AND
MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the January 16, 2008 Office Action, the period for reply being extended by
the attached Petition for Extension of Time, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.